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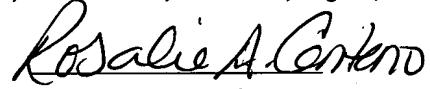
JC20 Rec'd PCT/PTO 23 JUN 2005

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

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Rosalie A. Centeno, Secretary

In the Application of Markus Hauf et al

Ser.No.: Not Yet Known (Based on PCT/EP2003/013387 filed November 28, 2003 and DE 102 60 673.0 filed December 23, 2002 and DE 103 29 107.5 filed June 27, 2003)

For: PROCESS FOR DETERMINING THE TEMPERATURE OF A SEMICONDUCTOR WAFER IN A RAPID HEATING UNIT

Filed on: June 23, 2005

Customer Number: 30996

Commissioner of Patents

Alexandria, Virginia 22313-1450

PRELIMINARY AMENDMENT ACCOMPANYING PCT NATIONAL STAGE APPLICATION

Sir:

Prior to examination, please amend the above-identified National Stage PCT application as follows:

Amendments to the Specification begin on page 2 of this paper.

Amendments to the Claims are reflected in the listing of claims, which begins on page 3 of this paper.

Remarks begin on page 10 of this paper.